Resonant tunneling in (110) oriented interband diodes


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Resonant tunneling in (110) oriented interband diodes

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Growth of high-quality Sb-based resonant tunneling diodes in the (110) orientation is demonstrated. The room-temperature current–voltage characteristics of the diodes are studied as a function of GaSb well width. Electronic band structure calculations including spin support the conclusion that the position of the GaSb light hole band with respect to the InAs conduction band is responsible for the strength of the negative differential resistance observed. The spin splitting of the heavy hole band is calculated to be larger than the light hole band suggesting that the observation of negative differential resistance may not be necessary or desirable for spin transport in these structures. © 2005 American Institute of Physics. [DOI: 10.1063/1.1862335]

Growth of quantum well devices in the (110) orientation is of interest because of applications to spintronics. A quantum well structure grown in the (110) orientation offers the possibility of a longer spin lifetime than the corresponding (100) structure, because the effective magnetic field in the reference frame of a moving charge in the crystal field is polarized along the growth direction. Consequently, the D’yakonov–Perel precessional decay mechanism for spin relaxation is suppressed for the (110) growth direction. Experimental evidence exists that longer spin lifetimes are indeed observed in the case of both arsenide and antimonide based systems grown in the (110) orientation with respect to their (100) counterparts.

Resonant interband tunneling devices (RITD) in the 6.1 Å material system have been proposed as nonmagnetic semiconductor electron spin filters in both (100) and (110) oriented heterostructures, although the design prerequisites are different. A nonmagnetic electron spin filter has two essential design criteria. First, the electron must experience an effective magnetic field to split the Kramer’s degeneracy of the spin states. In nonmagnetic spin filters of (100) orientation, the degeneracy of the spin states is removed not only by bulk inversion asymmetry (BIA) but also by the Rashba effect, which is a consequence of asymmetry built into the device by design. In this case, large crystal magnetic fields are produced within the plane of the heterostructures and perpendicular to the electron wave vector. These fields necessarily lead to fast precessional spin relaxation regardless of the orientation of nonequilibrium spin. In contrast, nonmagnetic spin filters of (110) orientation are designed to be symmetric, thus avoiding, in principal, Rashba fields that would cause spin precession and subsequent decay. The spin degeneracy in the (110) oriented spin filter is lifted as a consequence of bulk inversion asymmetry (BIA), which for a (110) oriented quantum well results in a crystal magnetic field oriented in the growth direction. Thus, in the (110)-oriented spin filter the growth direction is a natural quantization axis for spin, along which precessional spin relaxation is suppressed. As a second design criterion, there must be a net lateral momentum imparted to the electrons to produce a net spin polarization, which would otherwise be zero due to time reversal symmetry. In both types of spin filters, the lateral momentum can be imparted to the electron by means of a lithographically defined lateral side gate. Fabrication of such a device has been demonstrated for the (100) orientation, and application of the process to the (110) orientation is expected to be straightforward. In this letter we show that high quality growth of Sb-based RITD devices is achievable in the (110) orientation and we study the effect of GaSb well width on the presence of negative differential resistance (NDR) in the current–voltage (I–V) curves of such devices.

The calculated spin split electronic band structures for (110) AlSb/GaSb quantum wells with GaSb well thicknesses of 15 and 22 Å, respectively, are shown in Fig. 1. The band structures are calculated using a nonperturbative 14-band k·p nanostructure model in which BIA is included to all orders of the electron wave vector. In both of these relatively narrow well structures, the effect of confinement is to move the confined light hole band (LH1) below the InAs emitter conduction band edge such that the contribution to resonant tunneling through LH1 band is minimized. The heavy hole band (HH1) which is less affected by confinement is predicted in these calculations to lie above the InAs conduction band at zero bias. The calculations show that for this structure the spin splitting is larger in the heavy hole band. However, the observation of strongly peaked negative differential resistance (NDR) is believed to be associated with tunneling through light hole states in resonant interband tunneling structures. Therefore, the selection of a layer structure where strong LH-based NDR is observed may be undesirable for a spin filter device.

A series of RITDs was grown with the epilayer structure shown in Fig. 2. Growth were performed in a VG V80 III-V MBE machine equipped with shuttered EPI Group III evaporators, shuttered EPI-valved group V crackers, and having reflection high-energy electron diffraction and threshold photoemission as in situ diagnostics. Substrate temperatures were controlled by feedback from the substrate thermocouple, which was calibrated in reference to a CI Systems NTM1 optical temperature measurement system. Group III

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fluxes were determined by ex situ x-ray diffraction measurements of calibration superlattice structures and group V fluxes were determined by in situ uptake measurements using threshold photoemission. Gallium arsenide substrates of (110) ±0.1° orientation were obtained from WaferTech and used as received without further preparation. All substrates were subjected to a thermal oxide desorption in vacuum under group V flux. Following oxide desorption, a 1000 Å buffer of GaAs was deposited at 560 °C. The InAs n⁺ bottom contact layer was nucleated at this temperature and then ramped at 5 °C/min to a growth temperature of 460 °C for the remainder of the structure. Top and bottom contact layers were doped with Si to 5e19 cc⁻¹ and n-type spacer layers were doped with Si to 5e16 cm⁻³ as determined by independent growth and room temperature Hall measurements.

The V/III ratios during growth were typically on the order of 10:1. A characteristic of (110) growth is that a high V/III ratio, in excess of 30:1 at growth temperatures of 480 °C, is required to achieve smooth surface morphologies due to the reduced sticking coefficient of group V species on this orientation. The epilayers grown in the (110) orientation in our laboratory at a V/III ratio of 10:1 exhibited a directional haze when observed under a fiber optic light, in contrast to similar structures grown in the (100) orientation, which appeared specular and featureless under the same illumination conditions. A comparison of atomic force microscopy images of identical heterostructures grown in the (100) and (110) orientations on GaAs substrates is shown in Fig. 3. The surface morphologies of these heterostructures can be reasonably assumed to be derived from the mechanisms of strain relaxation of the InAs nucleation layer on the GaAs substrate. The morphology of the (110) heteroepitaxial layer is characterized by features with preferred orientation in the (001) azimuth and are most likely associated with slip steps from the two (111) planes which intersect the (110) plane.

As the (100) surface has four (111) planes available for dislocation slip, no net anisotropy is expected or observed in the surface morphology. Nevertheless, at the length scale of the images, 20×20 μm², both surfaces have a rms roughness value on the order of 2 nm, and the correspondence between a visible directional haze and successful device fabrication is not clear.

Three samples were grown with AISb barrier thicknesses of 15 Å and GaSb well widths of 15, 20, and 25 Å, respectively. A fourth sample was grown with a 20 Å AISb barrier and a 15 Å GaSb well. Devices were fabricated via a simple one mask process in which square Ti/Pt/Au metal features with 3, 5, and 10 μm side lengths were formed by a liftoff process. The square Ti/Pt/Au features subsequently served as a mask for a conventional wet etch to form mesas with the bottom InAs(n⁺) layer as a common ground plane for all of the mesa devices. Current–voltage characteristics were acquired by probing the square mesas directly. A comparison of I–V measurements for devices of dimension 5×5 μm² are displayed in Fig. 4. In Fig. 4(a) all three RITDs have AISb barriers of 15 Å thickness but the GaSb well thickness varies from 15 Å (solid curve) to 20 Å (dashed curve) to 25 Å (dotted curve). The device with a 25 Å GaSb well clearly exhibits NDR with a peak current of 1.4 mA and a peak-to-valley ratio of ~2. When the well width is reduced to 20 Å, although weak NDR is observed both the peak current and peak-to-valley ratio are reduced. At a well width of 15 Å NDR is no longer observed. This observation would suggest that the contribution of the light hole states to the tunneling
current has been minimized with this narrow well width and may be the condition desired for optimizing spin current. This is qualitatively supported by the calculated band structure of Fig. 1, where the LH1 band is 100 meV below the InAs conduction band at zone center for a GaSb well thickness of 22 Å, but is more than 180 meV below the InAs conduction band when the GaSb well is only 15 Å thick. The coupling between the electron and HH1 state is weak and it is important to maintain a narrow barrier width to maximize tunneling current in these devices. This is illustrated in Fig. 4 which compares the $I-V$ measurement of two devices with 15 Å well widths but having 15 Å AlSb barriers (solid curve) and 20 Å barriers (dashed curve).

In summary, we have successfully grown symmetric RITD structures in the (110) orientation and characterized the $I-V$ characteristics of these devices at room temperature. We have correlated the thickness of the GaSb well with the observation of NDR and will use this correlation in the growth of subsequent spin filter devices to investigate the importance of heavy hole tunneling on spin filter action.

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